

Abstract

An electret condenser 2 includes a fixed electrode 6, a vibrating electrode 5, an electretized silicon oxide film 7 formed between the electrodes, and silicon nitride films 8 and 9 formed so as to cover the silicon oxide film 7. The silicon oxide film 7 covered
5 with the silicon nitride films 8 and 9 is formed on the vibrating electrode 5.